Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/614,056	ANDO, TAKESHI	
Examiner	Art Unit	
Chuck Huynh	2617	

	0545				
	SEARCHED				
Class	Subclass	Date	Examiner		
Search	Update	5/25/2006	ar		
455	432.1	5/29/2006	at		
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INT	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Combined text	5/25/2006	at		
Class/subclass	5/29/2006	at		
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